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GAU 2851  
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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kenji NJSHI

Appln. No.: 08/994,758

Filed: December 19, 1997

For: PROJECTION EXPOSURE APPARATUS



Group Art Unit: 2851

Examiner: A. Mathews

\* \* \*

SUPPLEMENTAL AMENDMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Supplementing the Amendment filed May 11, 2000, please further amend the above-identified patent application as indicated below.

IN THE CLAIMS:

Please add the following claims:

1        --171. An apparatus according to Claim 143, wherein  
2        said first stage holds the original and said second stage  
3        holds the substrate, and wherein said first stage is  
4        provided above said second stage.--

1        --172. A scanning exposure method in which in  
2        synchronism with movement of a first object formed with a